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| <b>INFORMATION DISCLOSURE<br/>STATEMENT BY APPLICANT</b><br><br>(use as many sheets as necessary) |                        | <b>Complete if Known</b> |                    |
|   |                        | Application Number       | 10/608,855         |
|   |                        | Filing Date              | June 27, 2003      |
|   |                        | First Named Inventor     | Francesco CIOVACCO |
|   |                        | Group Art Unit           | 2811               |
|   |                        | Examiner Name            | Ori Nadav          |
| Sheet 1 of 1  | Attorney Docket Number | 2110-47-3                |                    |

| OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS |               |   |     |
|--|---------------|---|-----|
| Examiner<br>Initials *                             | Cite<br>No. 1 | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T 2 |
| ON   |               | Hong Xiao, INTRODUCTION TO SEMICONDUCTOR MANUFACTURING TECHNOLOGY, pages 258-259, (Prentice-Hall, 2001)   |     |
|  |               | CY Chang, SM Sze, ULSI technology (McGraw Hill, 1996)   |     |
|  |               | FF Chen, JP Chang, Principles of Plasma Processing (UCLA, 2002)   |     |
| ON   |               | <a href="http://www.lamrc.com/tech_1_1.cfm">http://www.lamrc.com/tech_1_1.cfm</a> (hardcopy of this Web page is attached), TCP Design (2008)  |     |
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| Examiner<br>Signature | ON | Date<br>Considered | 9/10/07 |
|-----------------------|----|--------------------|---------|

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